

online

Exploring Inside the LANSCE H- Ion Source with Laser Absorption Techniques

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Acknowledgements:

H- Ion source modelling team. I. Draganic, E. Henestroza, N. Yampolsky

Solidworks experts. B. Cantrell, J. Montross

Funding Provided by the Los Alamos National Laboratory LDRD program

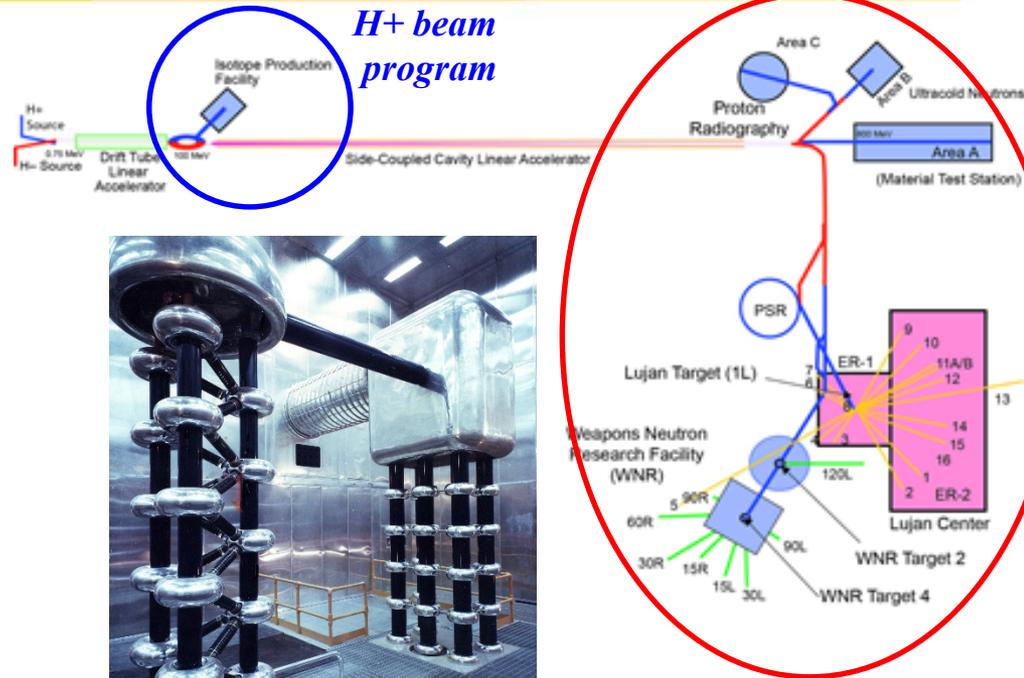
LA-UR-20-26755

Research Goals

- New LANL funding early 2020 to establish two new diagnostic tools using Laser absorption spectroscopy to measure/quantify:
 - The density of Cs inside the H- ion source
 - The H- beam density inside the H- ion source
- Diagnostics already developed for fusion based H- Ion sources, like ITER
- Successful diagnostic will:
 - Immediate
 - Optimize present LANSCE H- ion source performance
 - Assist/validate LANSCE H- ion source models
 - Short term
 - Provide insight to changes in ion source design to make improvements
 - Long term
 - H- ion source data for the global community
 - Demonstrate its capability for accelerated based H- ion sources.

The Los Alamos Neutron Science Center (LANSCE)

- **H⁺** and **H⁻** beams
 - Injection to 750kV using Cockcroft-Walton (C-W) Generators
 - H⁻ beam has 80kV pre-extraction inside its C-W dome
 - **H⁺ beam:** 100 MeV, Supports one program.
 - **H⁻ beam:** 800 MeV, supports multiple programs
- H⁻ beam parameters
 - 120 Hz, 10% D.F. (833μs pulse)
 - 14-16 mA of H⁻ current
 - Ion Source recycle every 4-5 weeks.
- Focus today is on H⁻ ion source.
 - What is the H⁻ current density inside the ion source?
 - What is the Cs density inside the ion source?
 - **Laser Absorption techniques can answer these questions!**



H⁻ beam program

<https://www.lansce.lanl.gov>

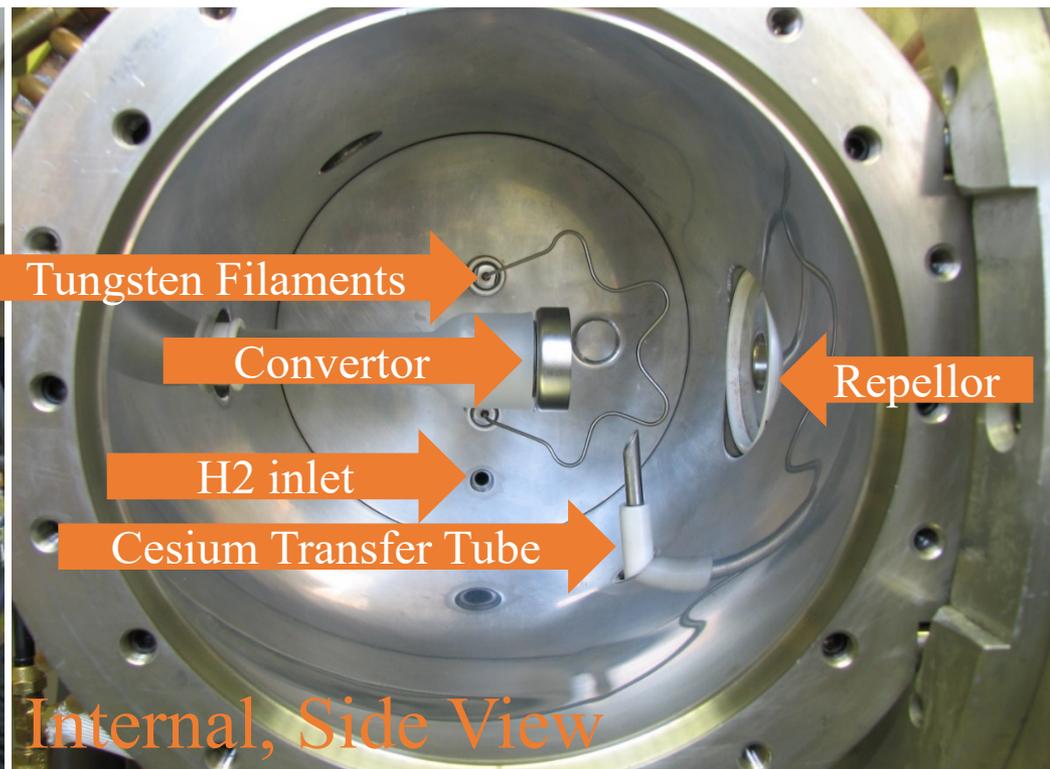
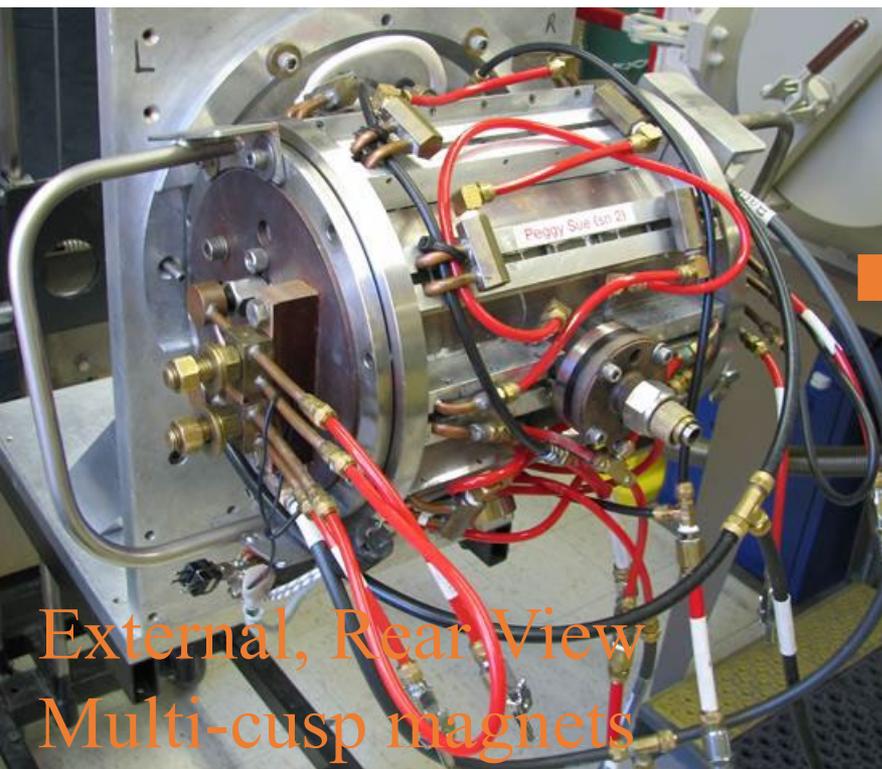


H⁺ ion source



H⁻ ion source

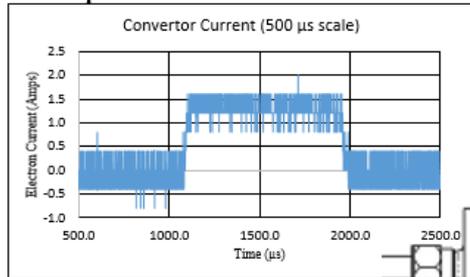
The LANSCE Multi-cusp Cesiumated Surface-Conversion H- Source: Photos



The LANSCE Multi-cusp Cesiumated Surface-Conversion H- Source: Ideal Operation

3.) Converter:

Negative potential bias attracts H⁺ ions low work function Cs gives up electrons to make H⁻ ions.



Pulse information:

Timing: 120 Hz, 10% D.F. 833 μs

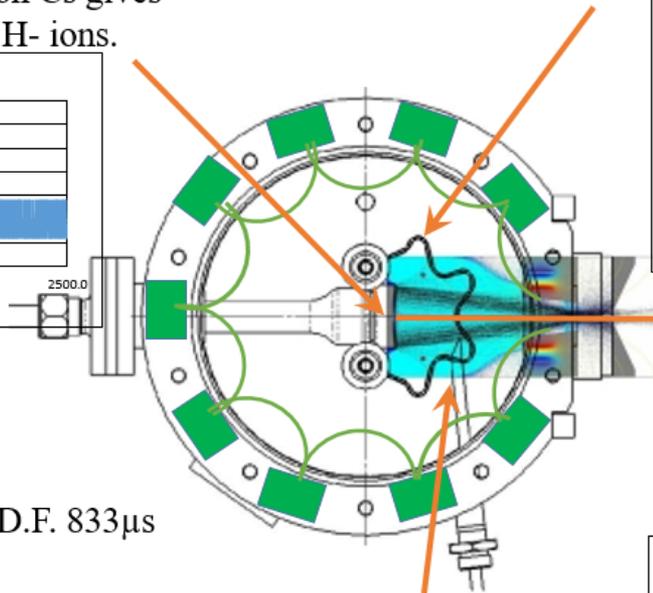
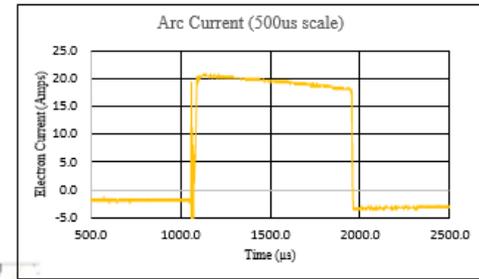
Arc: 20-40 Amps

Converter: 1-3 Amps

Repeller: 1-4 Amps

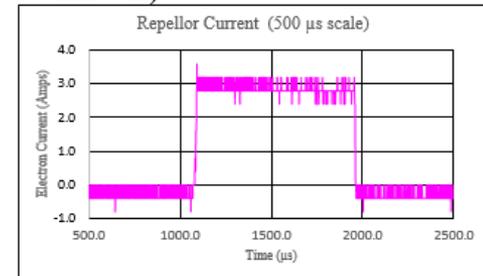
2.) Filaments:

Arc pulse ionizes H₂, creates plasma contained by multi-cusp field



4.) H- beam

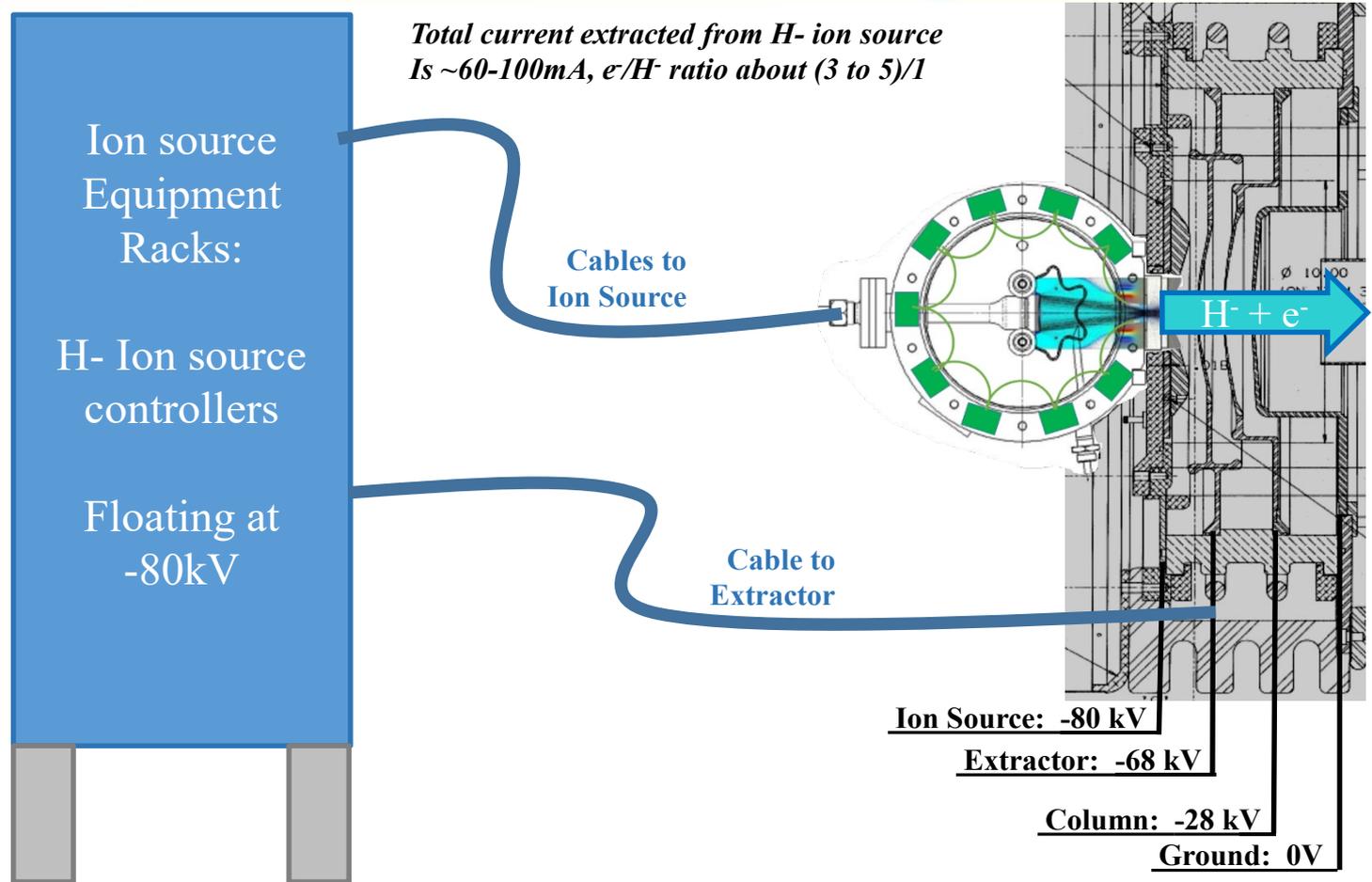
Rejected from Converter leaves Ion source. electron halo captured by Repeller. Then 80 kV Extraction (not shown)



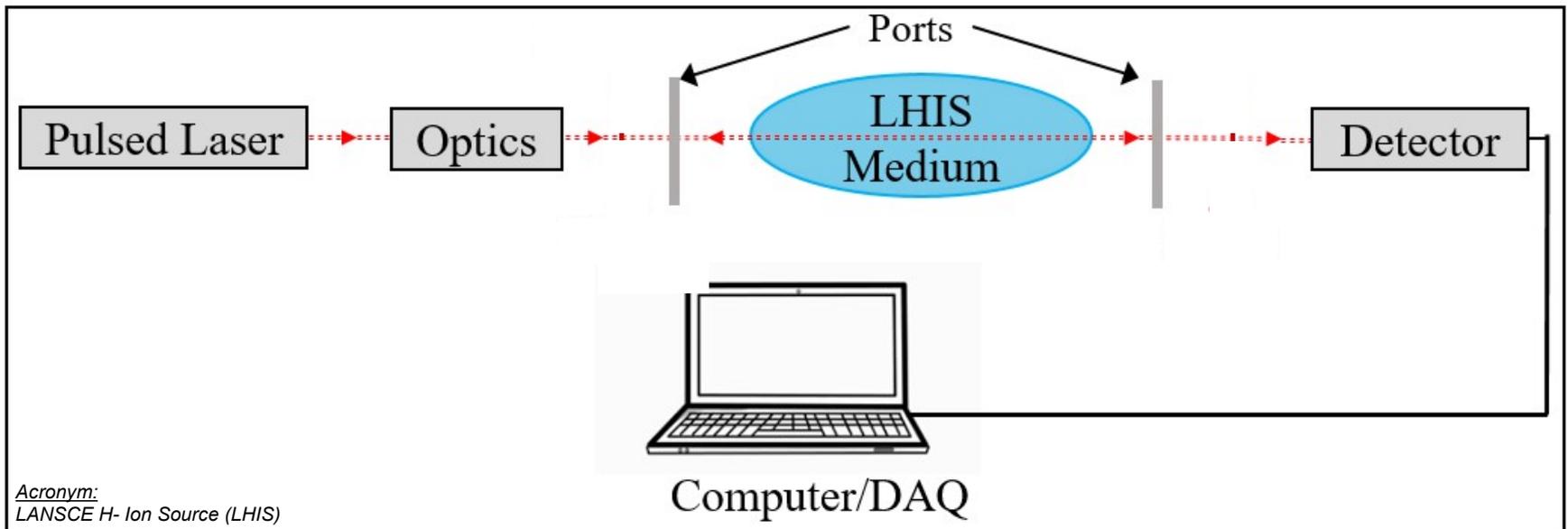
1.) Cesium:

Transfer tube deposits Cs continuously on converter surface. Replaces Cs sputtered during beam pulse

The LANSCE Multi-cusp Cesium Surface-Conversion Source with initial 80 kV extraction



Simple optical setup diagram. Laser Absorption Techniques (LAT)

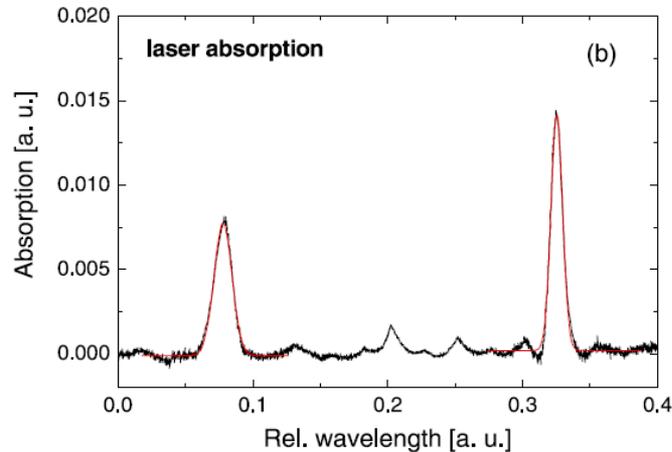


- *LAT* is a form of optical absorption spectroscopy.
 - high sensitivity and precision for a given atomic state
- Non-invasive, fast measurement that can directly monitor the cesium density inside in real time.
- Diagnose the real-time **Cesium** density inside source before, during, and after the beam pulse
 - will allow for the minimum-optimization of cesium
 - maximize H⁻ beam output while avoiding instabilities related to over-cesiation effects.

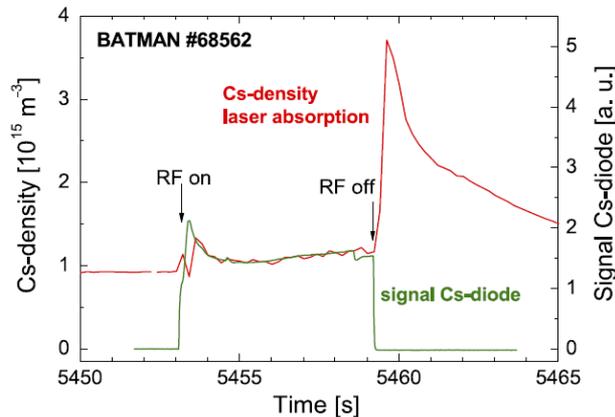
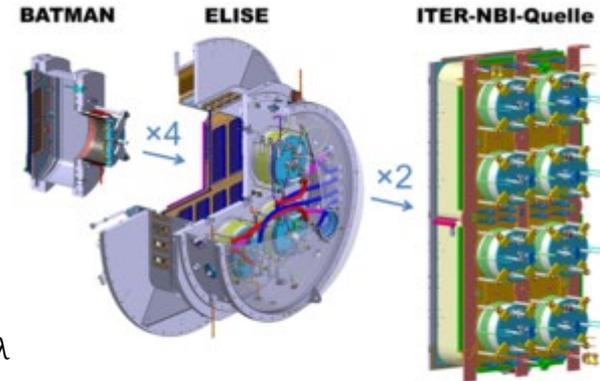
Measurements of Cs in BATMAN for ITER (LAT)

Jour. Phys. D: Appl Phys, vol. 44, no. 33502, 2011

<https://www.ipp.mpg.de/3704093/nabi>

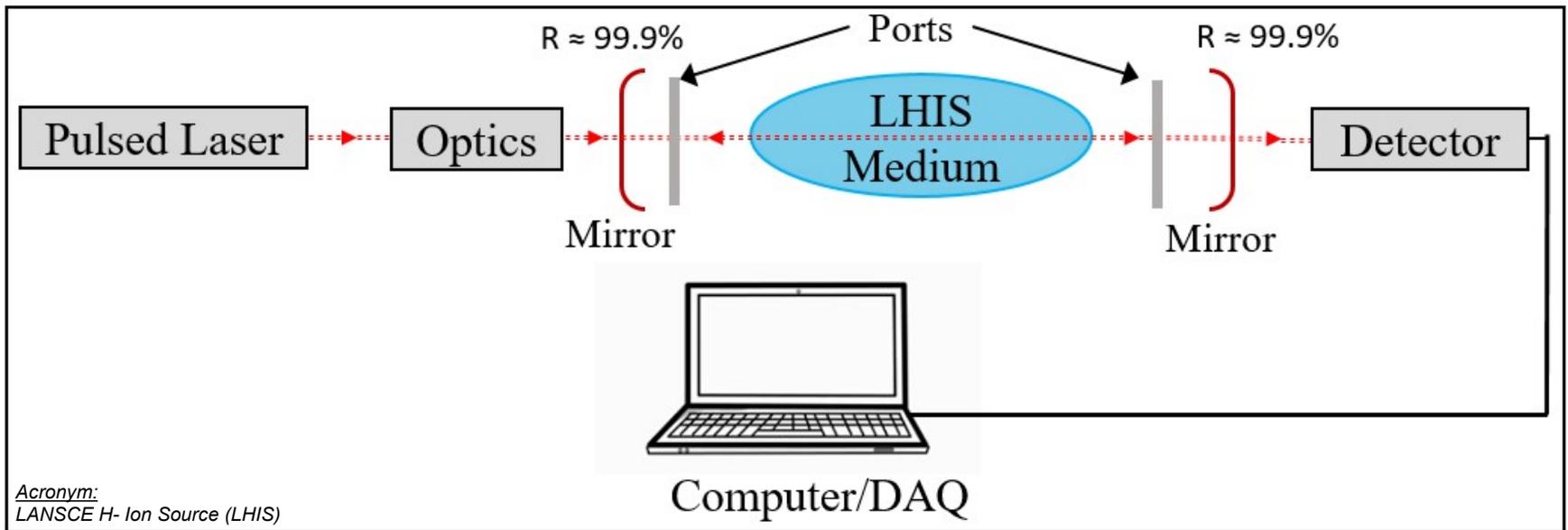


$$n_k = \frac{8\pi c}{\lambda_0^4} \frac{g_k}{g_i} \frac{1}{A_{ik}l} \int_{line} \ln \left(\frac{I(\lambda, 0)}{I(\lambda, l)} \right) d\lambda$$



- D2 line of Cs (852.1 nm)
- “during discharge the density of Cs atoms remains similar level as before which is quite surprising”
- “strong redistribution of Cs from the surfaces appears during the discharge”
- “...switched off the Cs density ... recombination of Cs ions to neutrals.”
- Cs density, temperature increase correlated

Simple optical setup diagram. Cavity Ring Down Spectroscopy (CRDS)

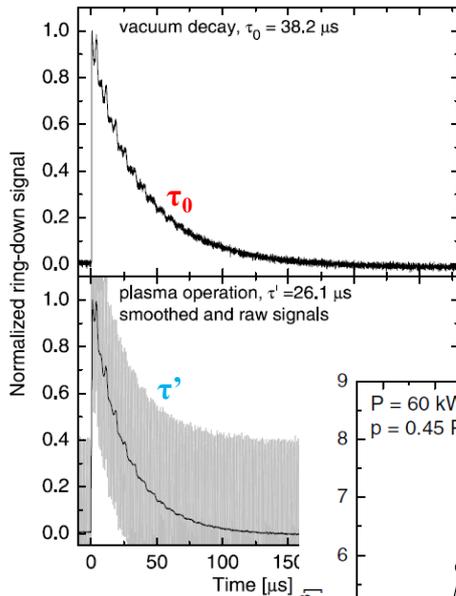


- CRDS introduces highly reflective mirrors to the LAT setup.
 - Signal is an exponential decay curve related to the density, as well as the mirrors' reflectivity
- Non-invasive, fast measurement that can directly monitor the **H- density** inside source
 - Measure H- photo-detachment process. (>0.75 eV, $\sigma = 3.5 \times 10^{-21}$ m²)
 - Mirrors assist measuring small cross section.
 - Line-of-sight integrated measurements across several points inside the ion source
- Knowing the H- density profile inside ion source will
 - allow for capitalization of the LHS performance,
 - fast-track innovative improvements to its research & development.

Measurements of H- in BATMAN for ITER (CRDS)

Plasma Sources Sci. Technol., vol. 18, no. 025004, 2009

<https://www.ipp.mpg.de/3704093/nmbi>



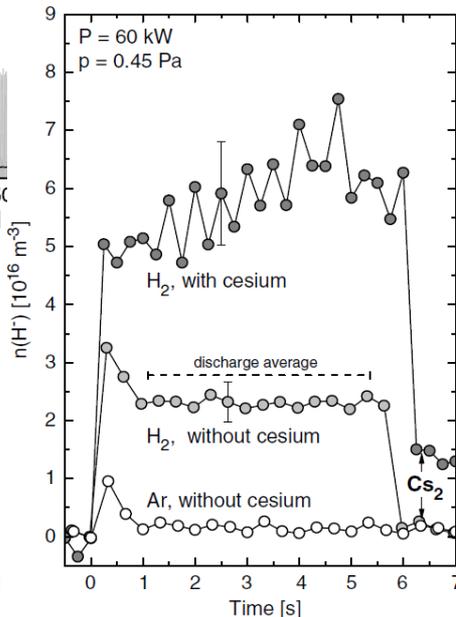
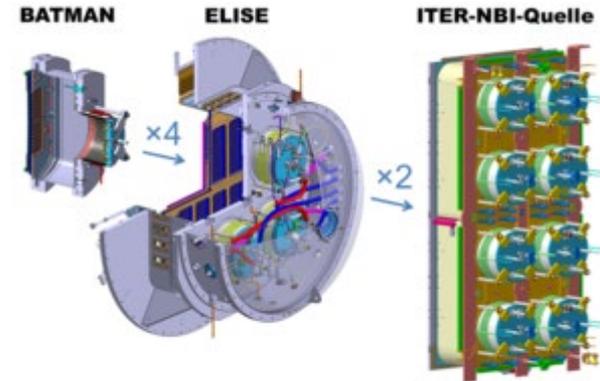
$$I(t) = I_0 \cdot e^{-\frac{t}{\tau}}$$

$$\tau = \frac{d}{c(1-R)}$$

$$\alpha = \frac{1}{c} \left(\frac{1}{\tau'} - \frac{1}{\tau_0} \right) \cdot \frac{d}{L}$$

$$n = \frac{\alpha}{\sigma}$$

τ : decay time
 α : coeff. of absorption
 σ : cross section
 d : cavity length
 L : plasma length



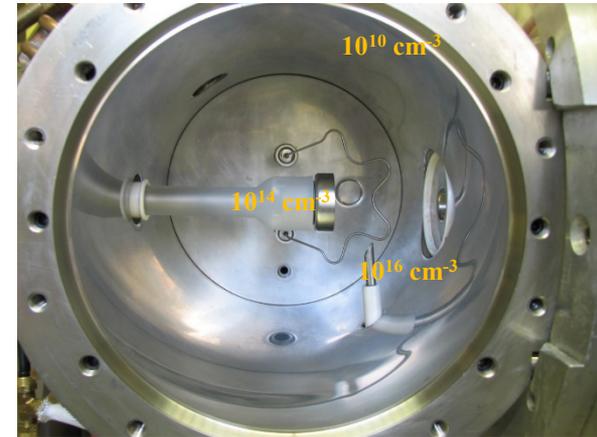
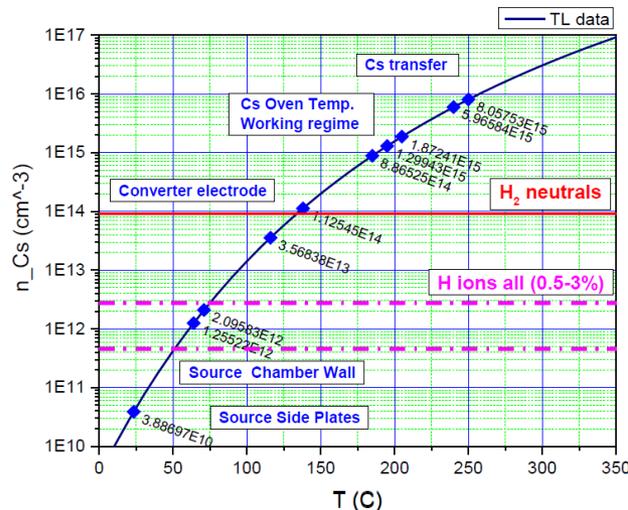
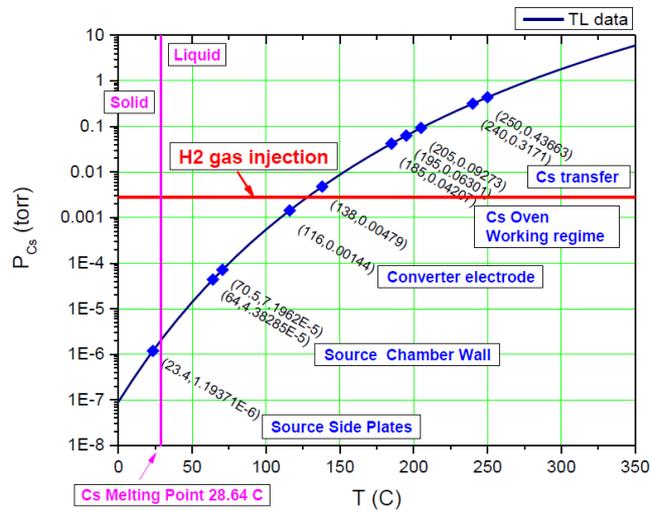
- Nd-YAG laser (1024 nm)
 - measures H- detachment, avoids other processes (Cs, H₂, etc)
- Challenges:
 - Uncertainty in L
 - Mechanical vibrations

Comparison of ITER & LANSCE ion sources

- Fusion source (ITER) vs Accelerator source (LANSCE)
- Seconds long pulse (ITER) vs ~ 1 ms pulse (LANSCE)
 - New challenge for Cs measurement
 - Similar challenge for H⁻ measurement
- RF source (ITER) vs Filament driven source (LANSCE)
 - Windows contamination from Cs (ITER and LANSCE)
 - Additional contamination from W (LANSCE)

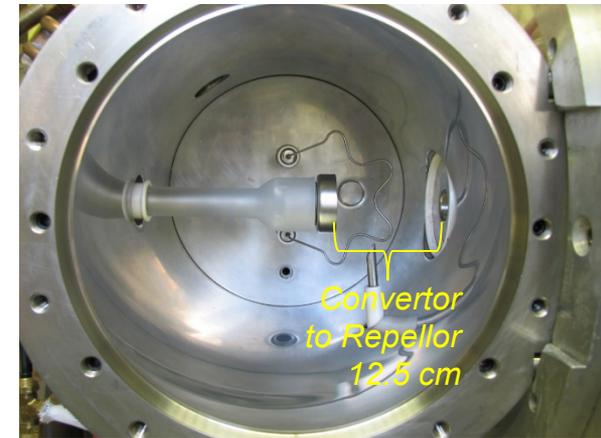
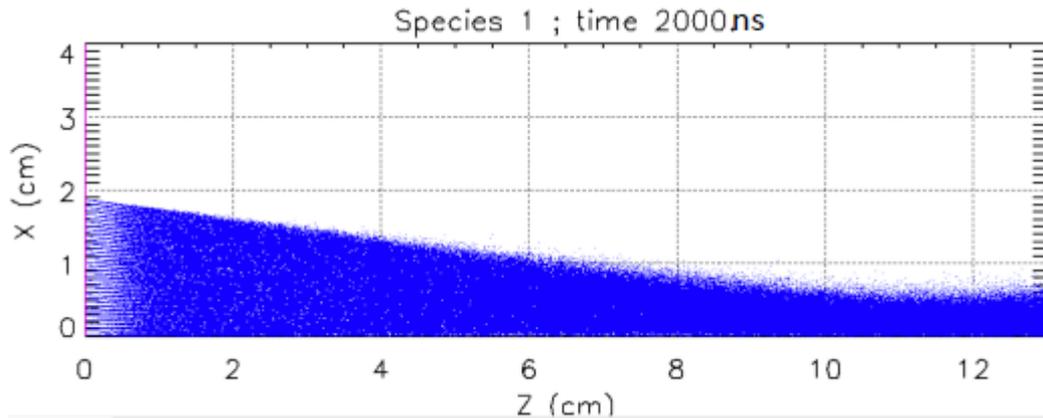
Model estimates for Cs Density measurement.

I. Draganic, L. Rybareyk. "Recent Results in Modeling of LANSCE H- Surface Converter Ion Source." In Proc. ICIS'17. Geneva



- Basic Cs Temperature/Vapor Pressure calculations
- $10^{10} cm^{-3}$ near the walls.
- $10^{14} cm^{-3}$ convertor face
- $10^{16} cm^{-3}$ at Cs transfer port
- *LAT will help study interplay between Cs transfer port, convertor electrode, wall coating.*

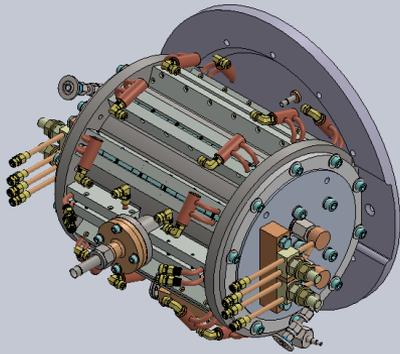
Model estimates for H- Density measurement.



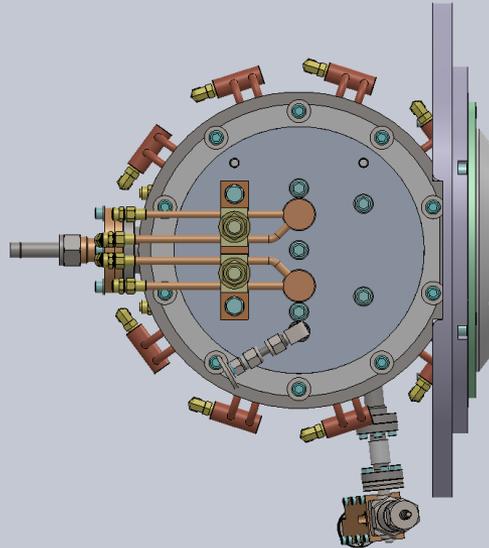
- See E. Henestroza et al. “Transport of a negative ion beam through a hydrogen plasma”
- Poster session P1, Abstract #57
- *“the beam is fully neutralized and the mean free path for extinction is ~ 20 cm producing a 50% drop in current for the 12.5 cm transport length”*

LANSCCE H- Ion Source Side-plate modification.

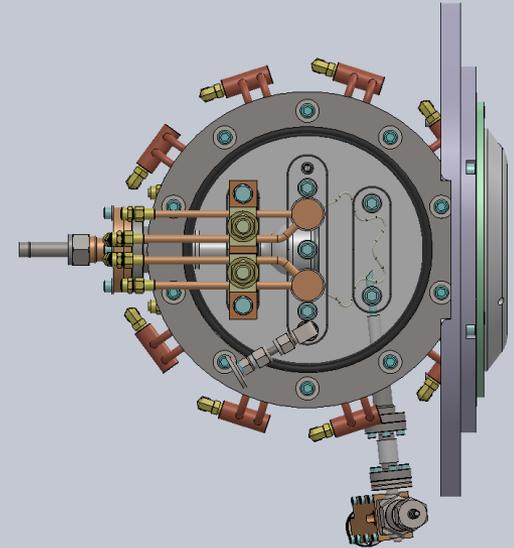
Isometric View



Side View



Transparent view

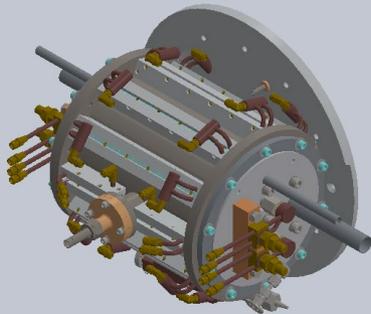


Solidworks Assembly File

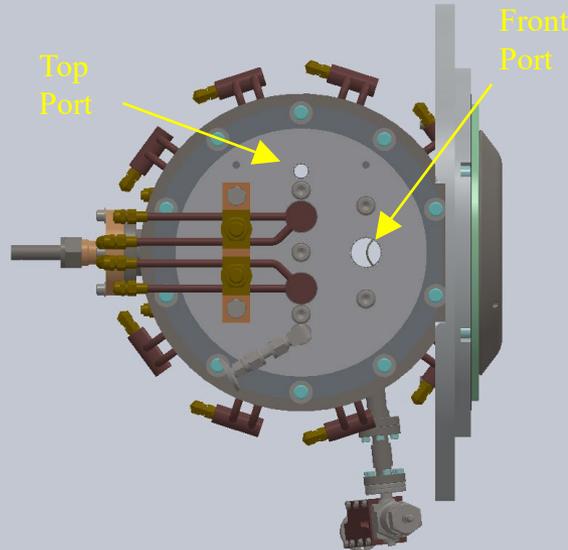
Challenge: Avoid water-cooling, magnets, o-rings for ports

LANSCCE H- Ion Source Side-plate modification.

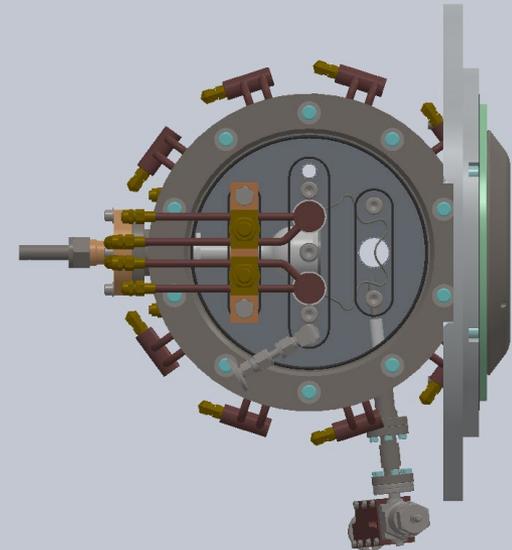
Isometric View



Side View



Transparent view



Solidworks Step File

Challenge: Avoid watercooling, magnets, o-rings for ports

Phase 1 side-plate design: Simply put ports where we can

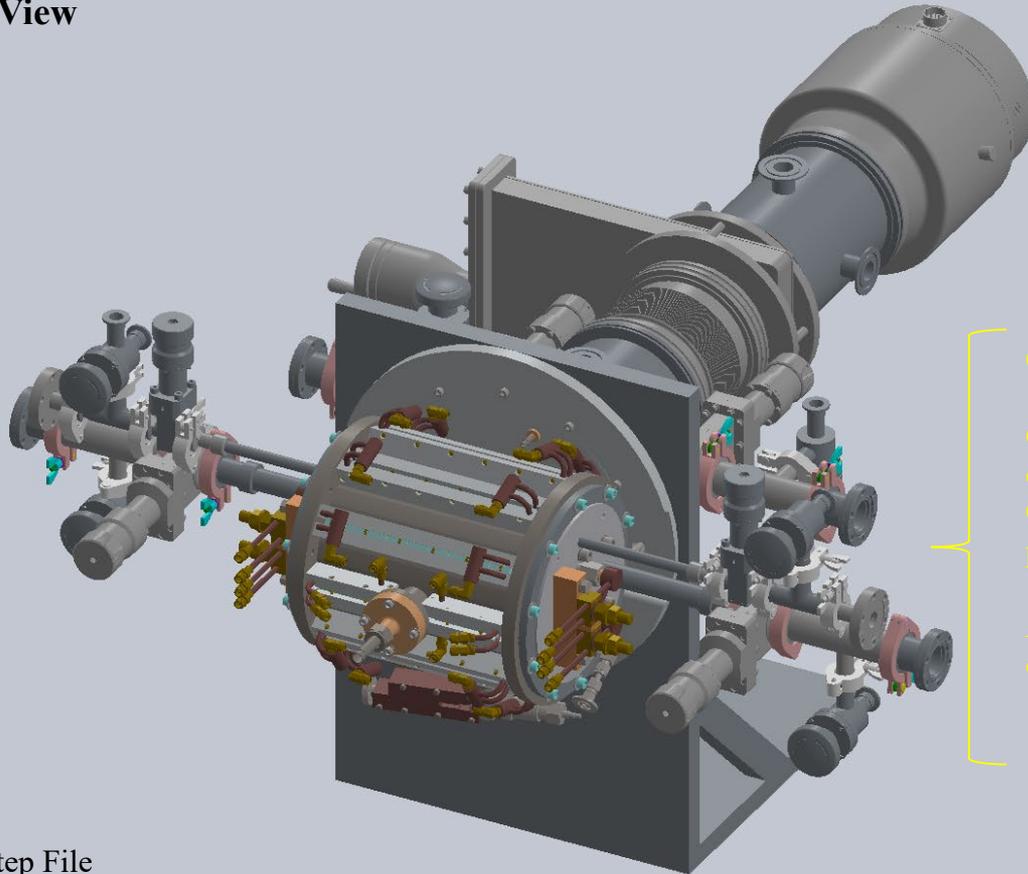
Top port to see background Cs density.

Front port for H- beam, Cs transfer port measurement.

Mesurement Challenge: Measure both sides of W filaments

Simple Laboratory setup

Isometric View



Challenge:
Optical port
contamination

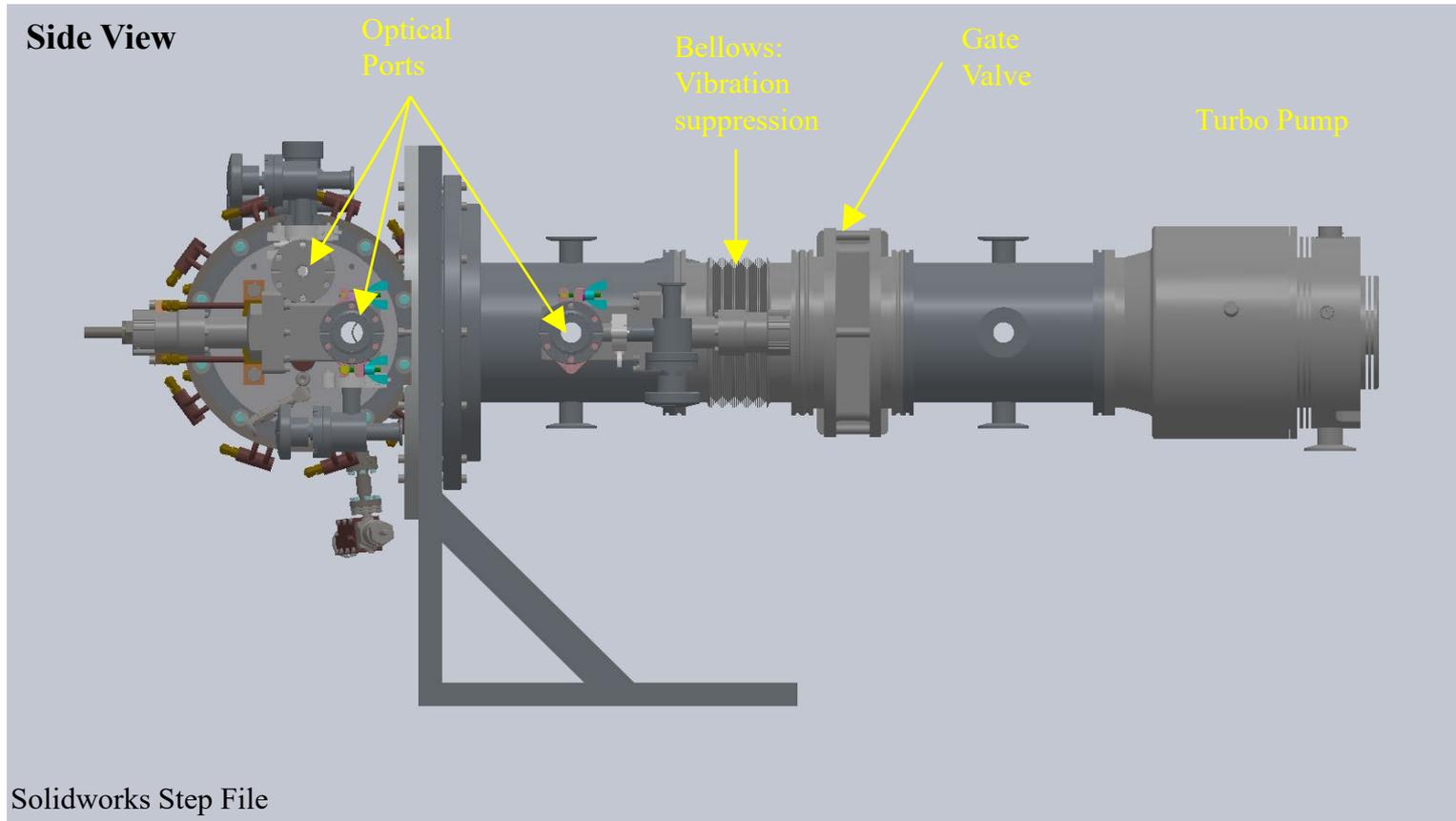
Optical ports setup:

Gate Valves to open/close
optical path to block W,
Cs deposits during
preparation

Angle valves to rough out
optical lines.

Solidworks Step File

Simple Laboratory setup



Outlook

- Covid19 delayed many milestones
 - Collaborative trip between Max Planck IPP ITER group postponed indefinitely
 - Laser lab calibrations delayed.
- Outlook
 - Begin Cs laser calibrations next month.
 - Cs density measurement complete early 2021.
 - H- density measurement complete by mid/end 2021.

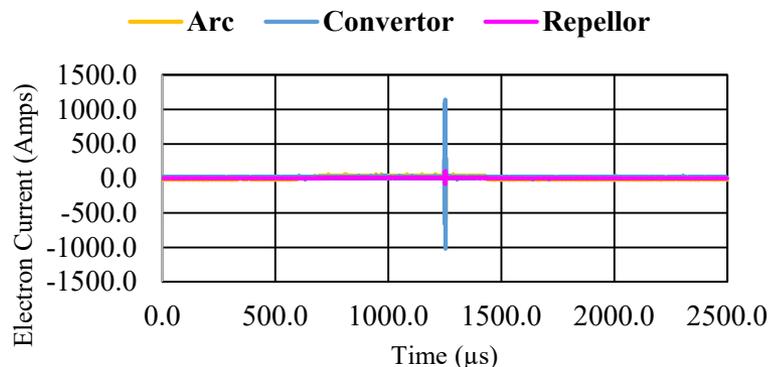
Video Release Information

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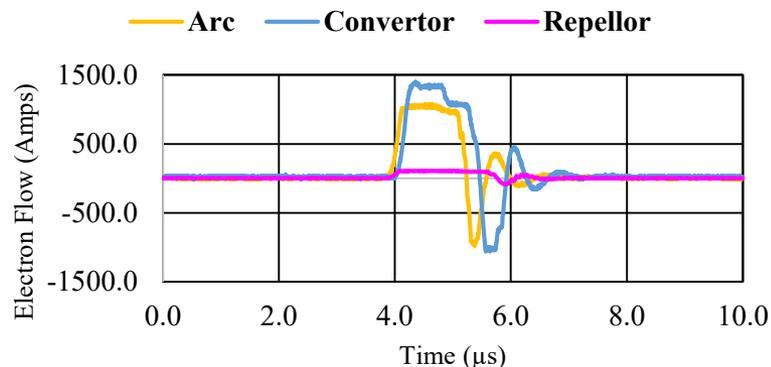
Backup

What are Arc Transients?

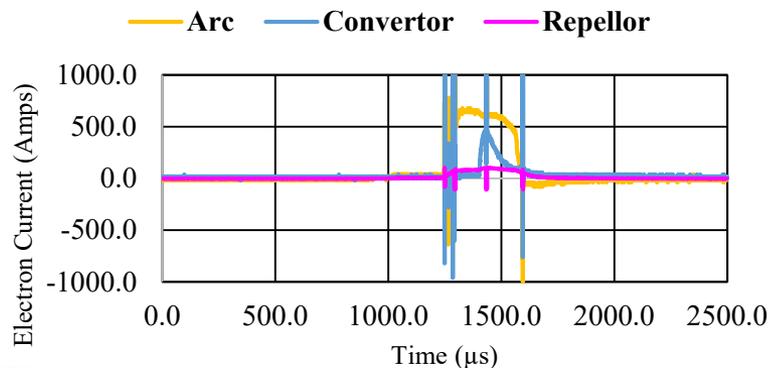
Small Transient (500 μ s scale)



Small Transient (2 μ s scale)

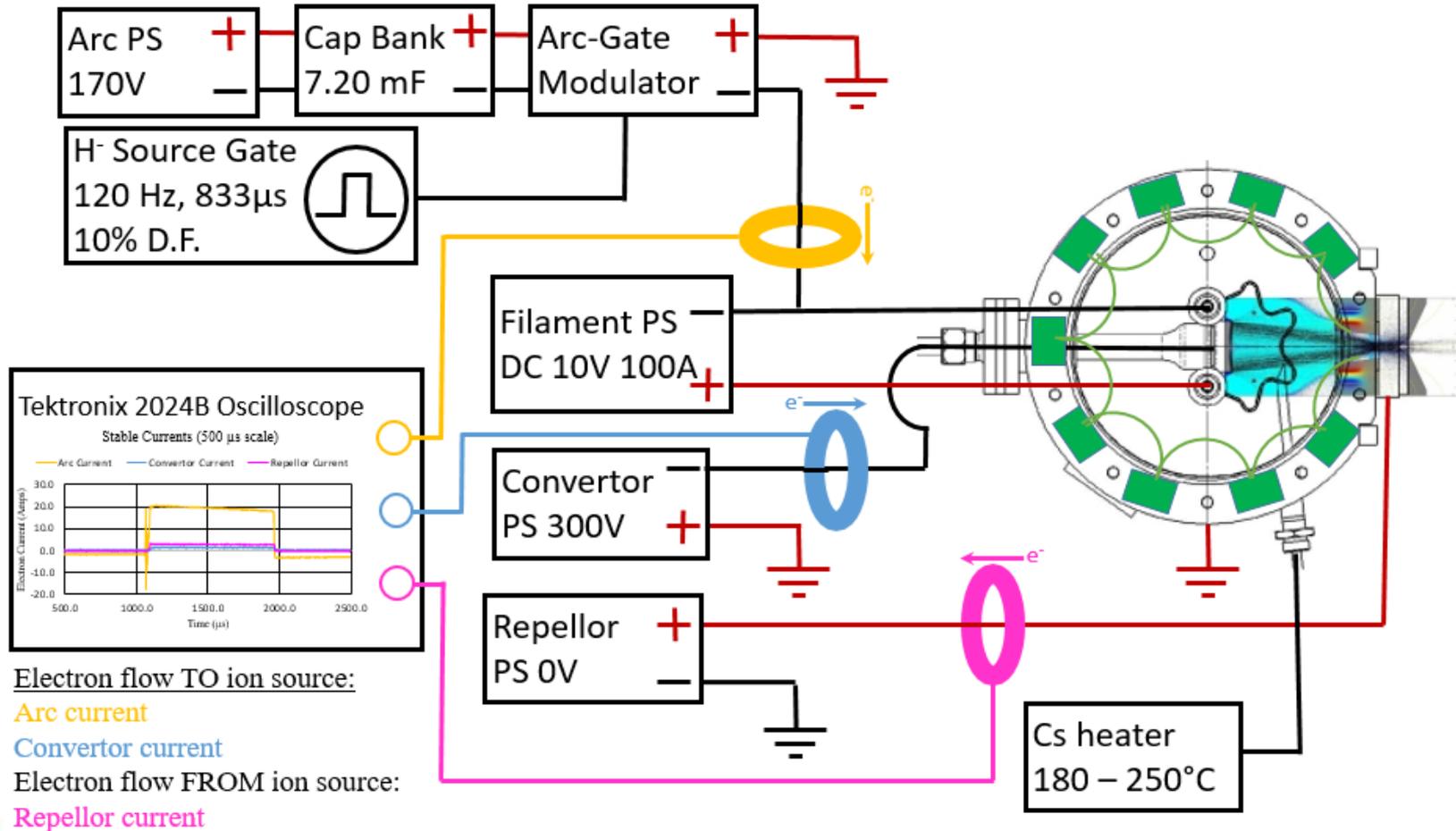


Large Transients (500 μ s scale)



- High Current transients in the ion source Arc current observed during LANSCE Operations.
 - Trigger scope just above nominal Arc current
- Small Transients (10-20/hr)
 - a few μ s, $\sim 10^3$ Amps
 - Saturates fiber-optic bandwidth
 - **Don't effect beam stability (usually)**
- Large Transients (0-4/hr)
 - Hundreds of μ s, $\sim 10^2$ Amps
 - Effect beam output
 - **Effect beam stability, 80kV extraction arc down!**

H- Ion source controls



Electron flow TO ion source:

Arc current

Converter current

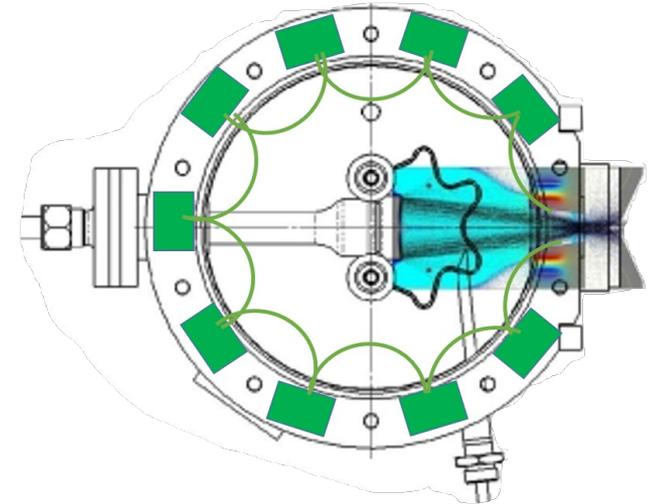
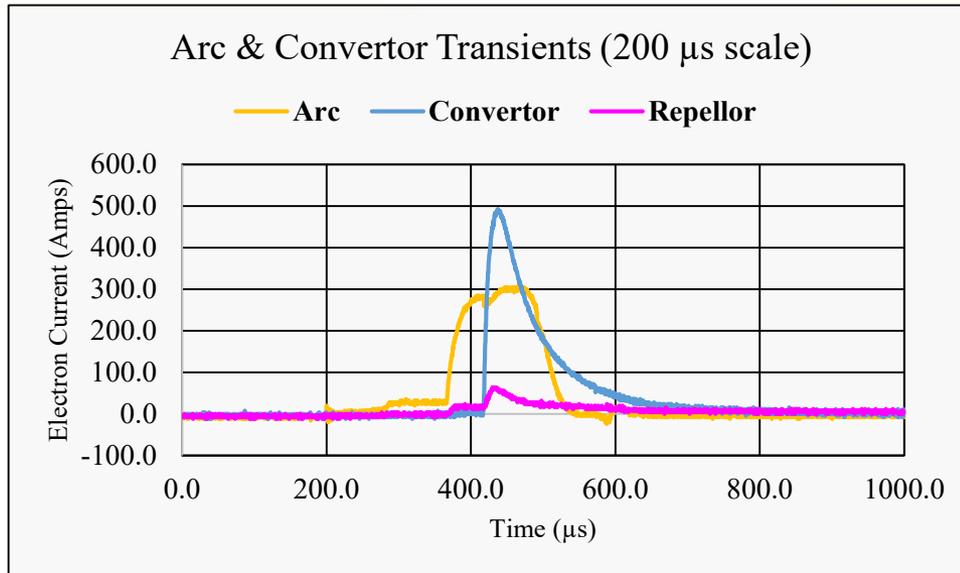
Electron flow FROM ion source:

Repellor current

ISTS Observations. Transients Rates: Cesium

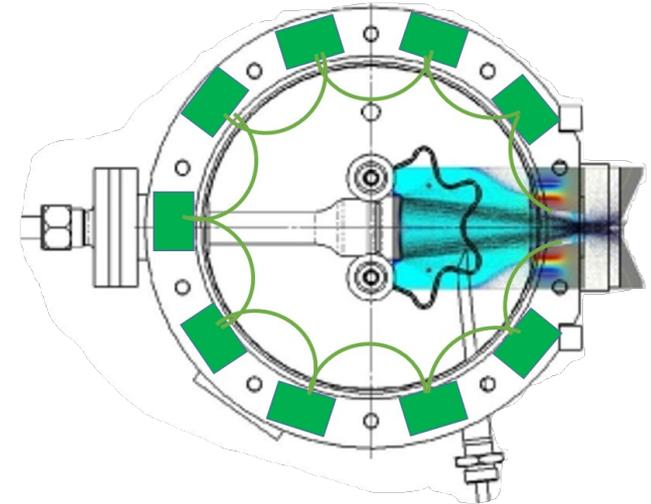
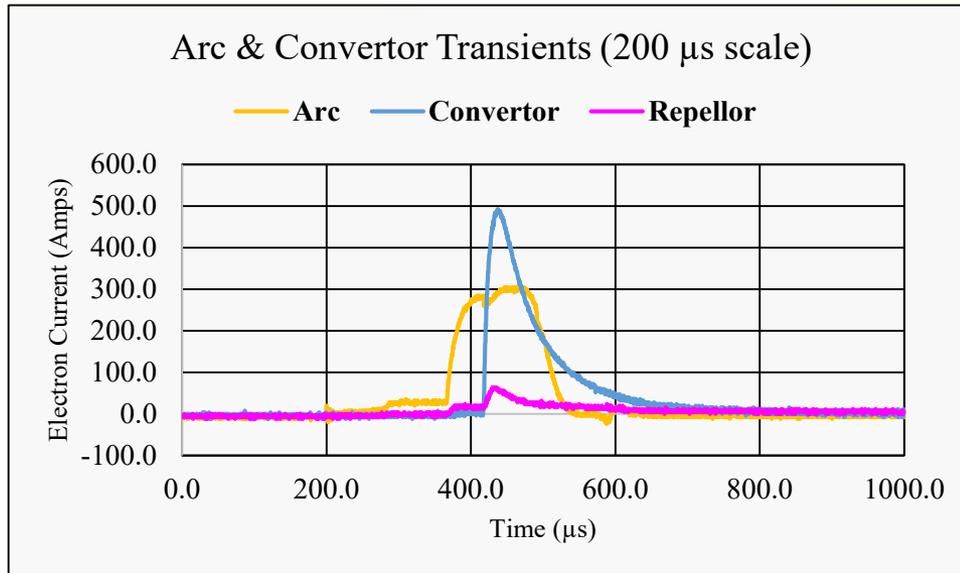
- No Cesium No Arc Transients
 - Ran for a few days before opening Cs Oven
- **Immediately into Transferring Cesium, we got Transients!**
 - In General, Higher Cesium Temperature lead to more Transients
- Other tests (with Cesium)
 - Convertor Voltage adjustments had minimal effects.
 - Water Chiller temperature had minimal effect.
- Other Observations
 - Linear rate: Single transients are random, but were linear averaged over a day.
 - Cold starting the source leads to many in a row. dI/dt effects?
 - Events always occurred during H- source timing gate pulse, i.e. with plasma in source.

ISTS Observations. Large Transients Observed



- Most transients observed were of the large transient types, i.e. a *surge*
 - Small, μ s transients were not seen. (80kV related?)
- Large surges seen on **Arc** also realized on **Converter**
- Arc & Converter Transients can occur together, or separate. Arc surge usually lead converter spikes, but not always.
 - Both:ArcOnly:ConvOnly ratio is about 3:2:1
- *Essentially, Arc and Capacitor circuits are shorted inside the source.*

ISTS Observations. Large Transients Observed

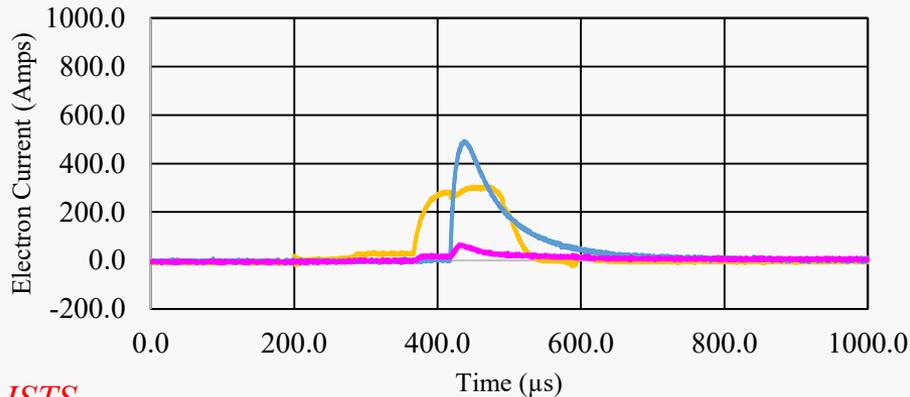


- **Arc** surges sustained by capacitor bank.
- **Converter** surges drop off immediately—no capacitor bank on converter PS.
- Repeller reacts to Arc and Converter surge,
 - Response like a “solid angle”

Large Transients: ISTS Observation vs LANSCE Production

Arc & Converter Transients (200 μ s scale)

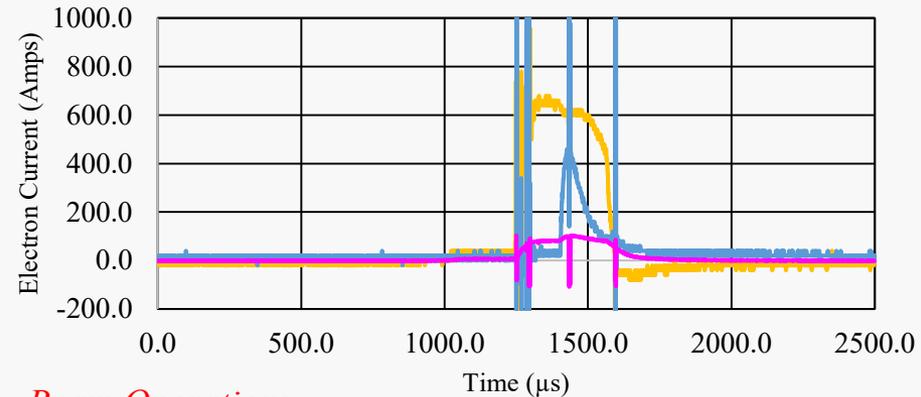
— Arc — Converter — Repellor



ISTS

Large Transients (500 μ s scale)

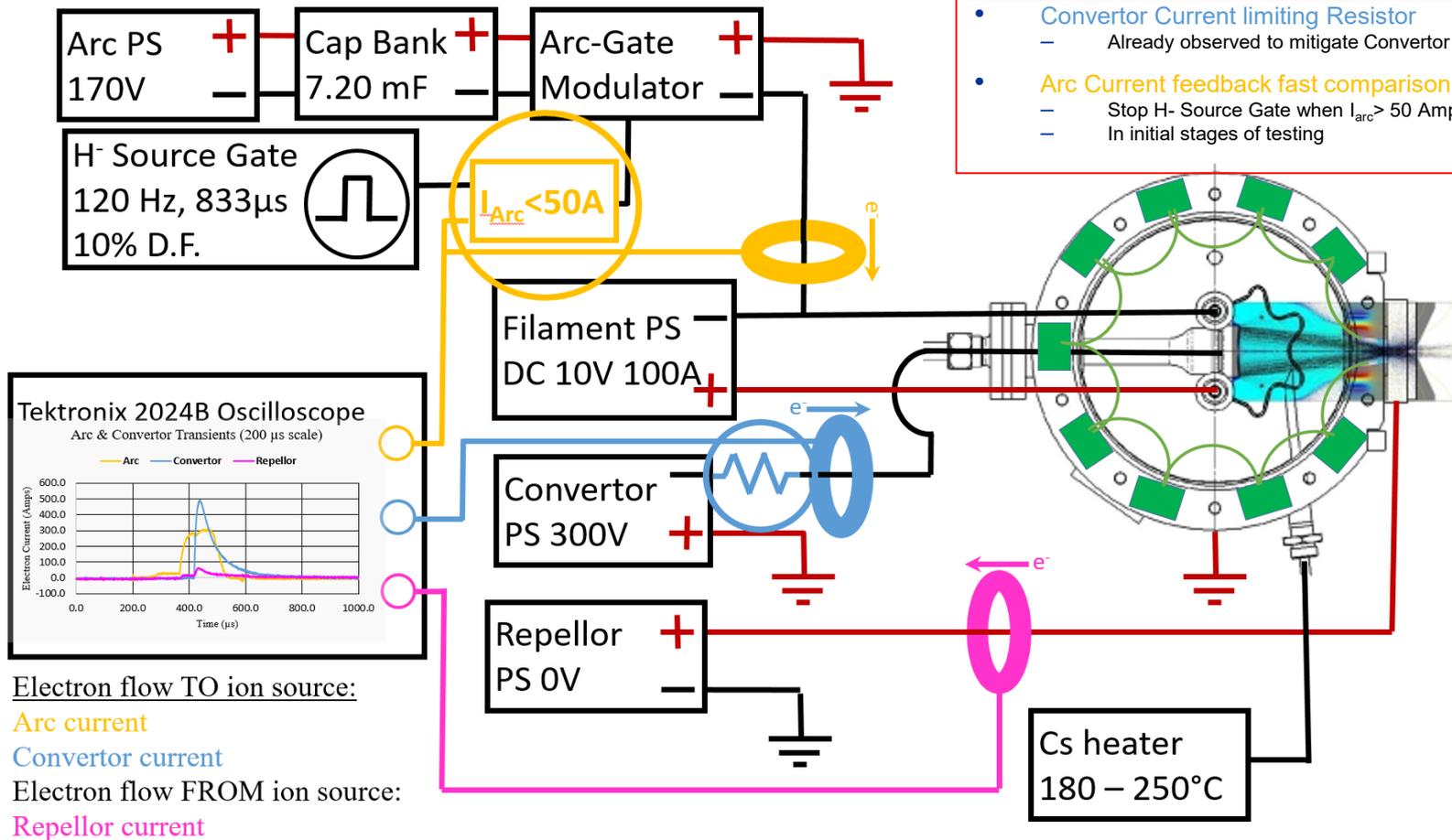
— Arc — Converter — Repellor



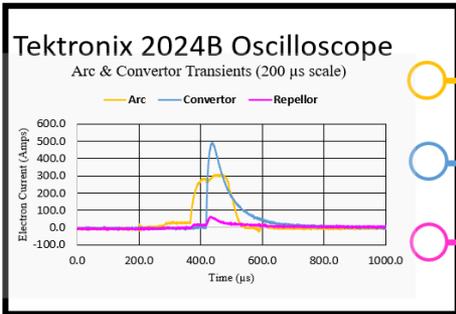
Beam Operations

- **Arc** surges: 300 Amp vs 600 Amps
 - Different Cap bank values, different arc modulators leads to different input impedance.
- **Converter** surges: Comparable
- **Repeller** response: Comparable

Mitigation of Surges



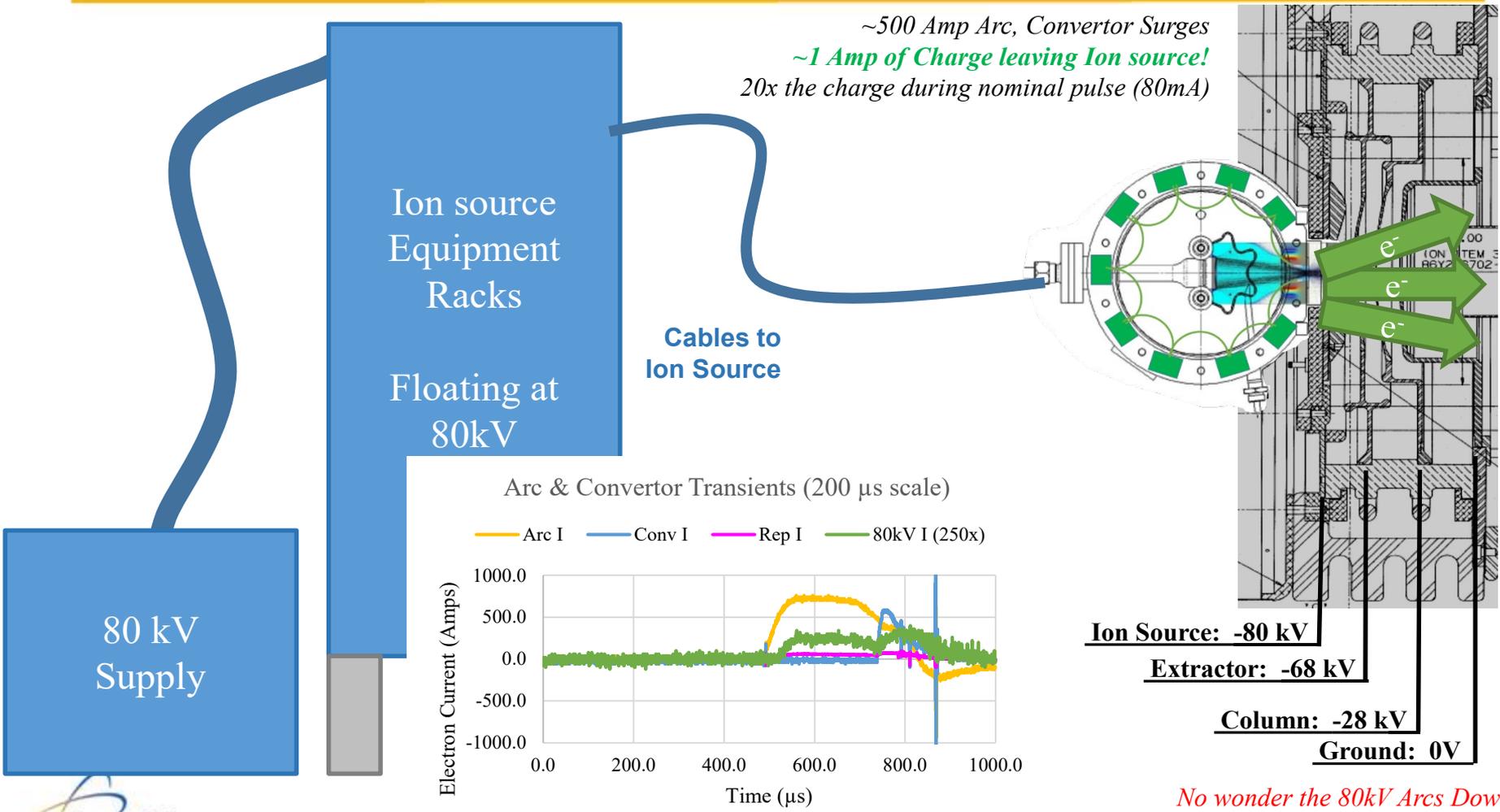
- **Converter Current limiting Resistor**
 - Already observed to mitigate Converter surges
- **Arc Current feedback fast comparison**
 - Stop H- Source Gate when $I_{arc} > 50$ Amps
 - In initial stages of testing



Electron flow TO ion source:
 Arc current
 Converter current

Electron flow FROM ion source:
 Repellor current

Large Transient observed with 80kV (June 2019)



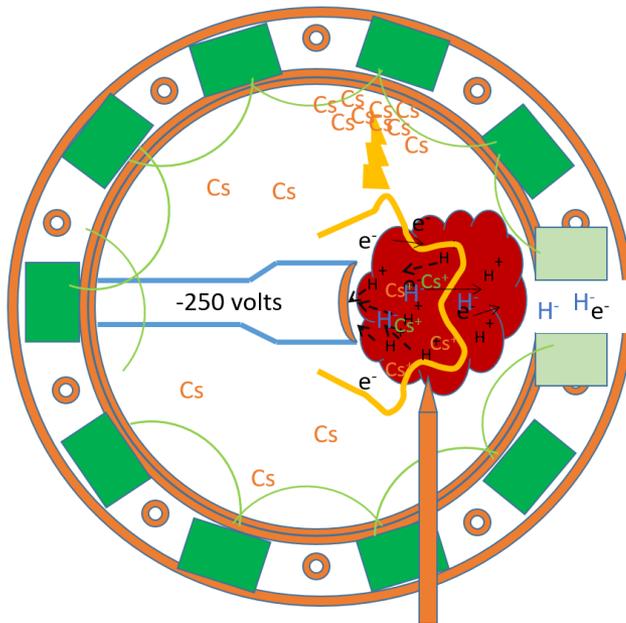
No wonder the 80kV Arcs Down

Mitigating is one thing, but what is the cause

The main culprit is Cesium!

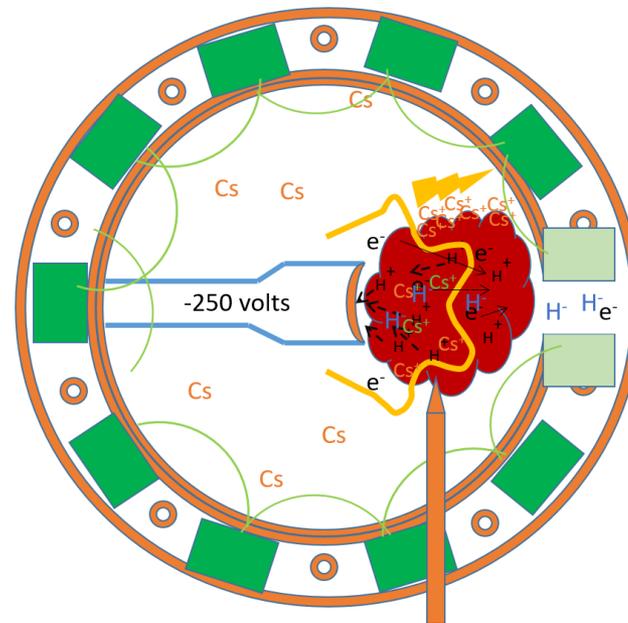
Cartoon of Cold Cs Deposit

Does a cold deposit of Cs short out the Arc and/or convertor?

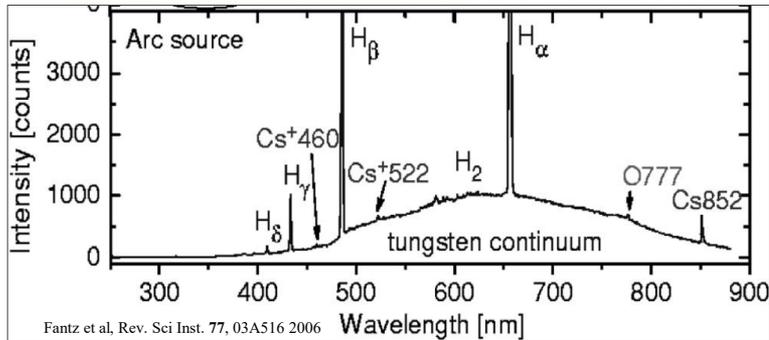


Cartoon of Non-neutral Plasma

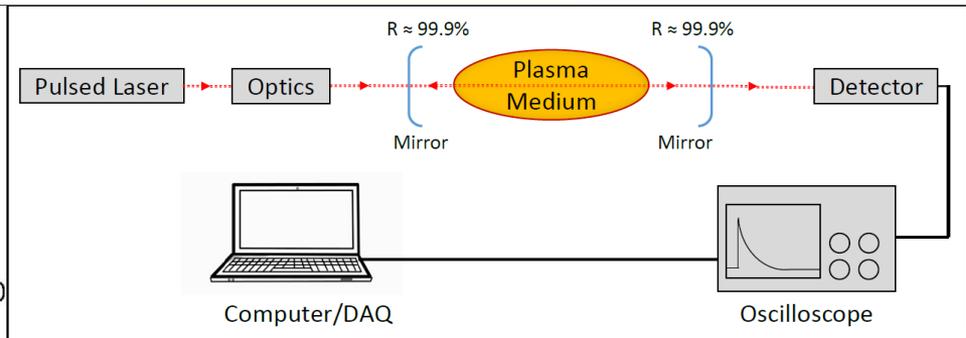
Does excess Cs⁺ in the plasma short out the Arc and/or convertor?



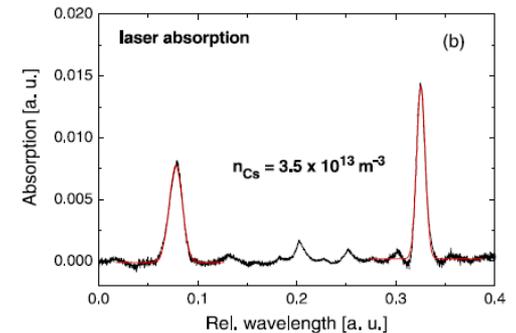
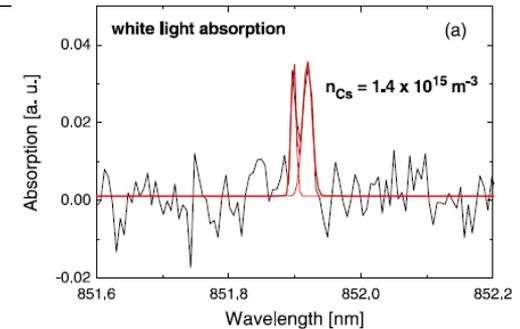
Need Laser Absorption Spectroscopy Plasma Diagnostics to identify true cause.



Fantz et al, Rev. Sci. Instr. 77, 03A516 2006



- Laser tuned to Cs emission (852.1 nm) can quantify Cs in ion source.
 - Fast quantitation: Individual Pulse Cs densities.
 - Disentangle cold cesium effects from cesiated plasma effects
- Currently seeking funding



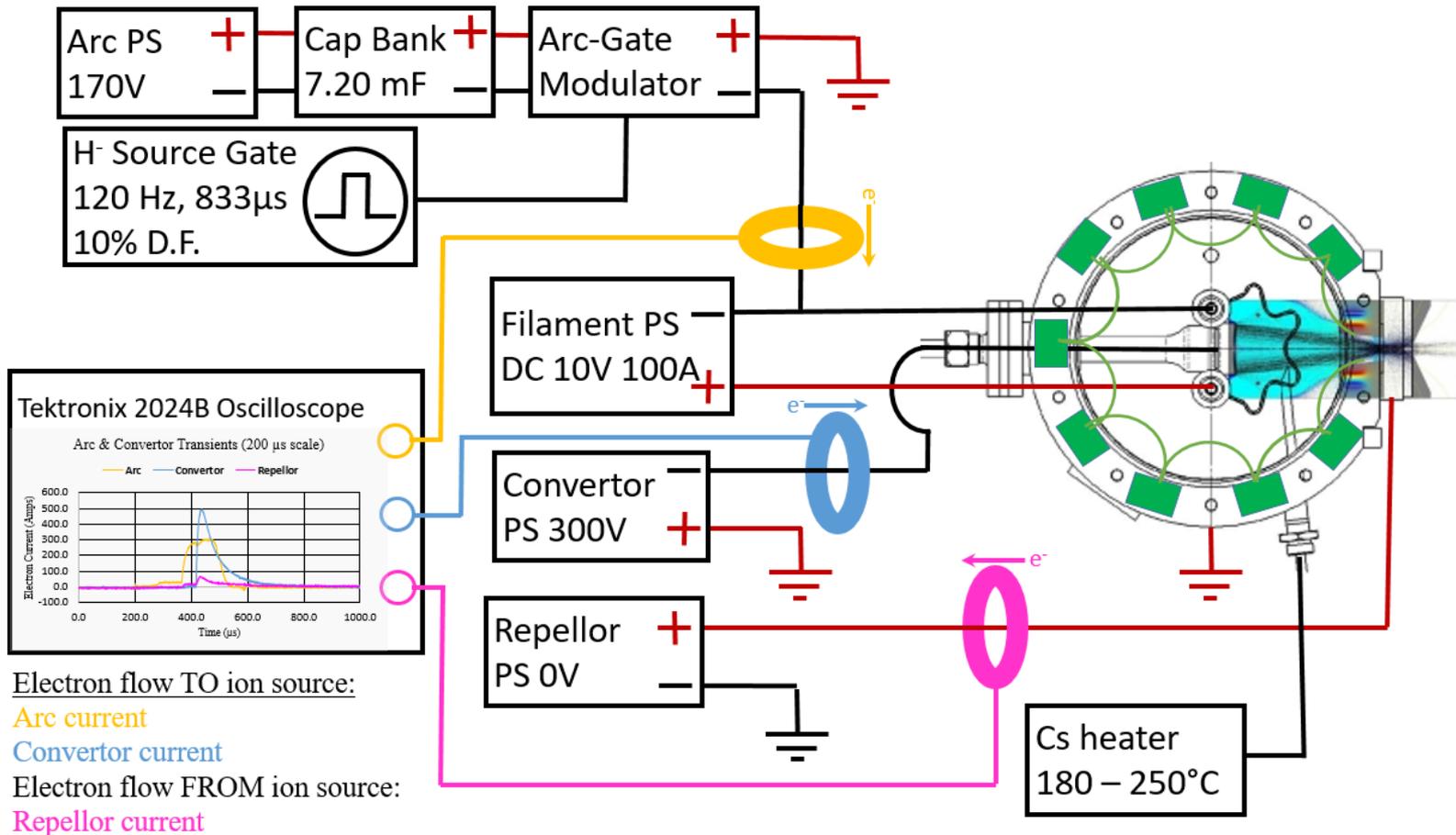
U. Fantz, C. Wimmer J. Phys. D 44 (2011) 335202

Conclusions

- Successful diagnosis of Large Transients in ion source
- Mitigation controls are currently being studied
- Seeking proposal funding for Plasma Diagnostics using Laser Absorption Techniques.

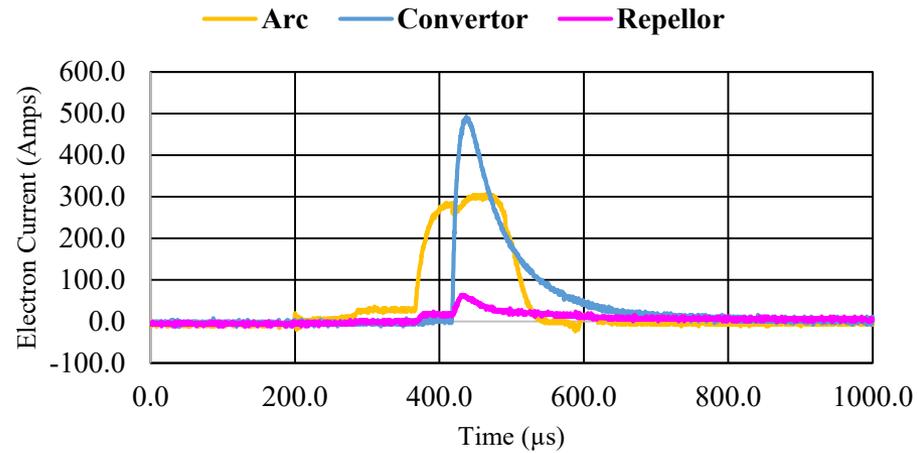
Backup

Experimental Setup: Measured Surge

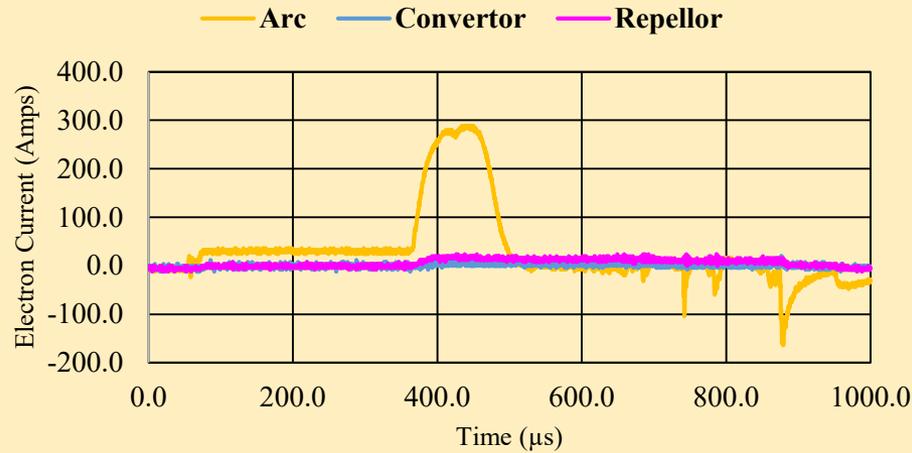


Both: Arc Only: Conv Only

Arc & Convertor Transients (200 μ s scale)



Arc Transient Only (200 μ s scale)



Convertor Transient Only (200 μ s scale)

